

<b>Notice of References Cited</b>	Application/Control No. 10/569,580		Applicant(s)/Patent Under Reexamination GOTO ET AL.	
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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0228847	12-2003	Matsumoto, Mitsuyoshi	455/90.3
*	B	US-2001/0004269	06-2001	Shibata et al.	348/333.06
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